



INFORMATION
DISCLOSURE
STATEMENT BY APPLICANT

Sheet 1 of 1

Application Number: 10/646,467
Filing Date: August 22, 2003
First Named Inventor: Kenneth COLLINS, et al.
Group Art Unit: ~~Unknown~~ 2812
Examiner Name: ~~Unknown~~ GHYKA
Attorney Docket Number: 6915 P06

U. S. PATENT DOCUMENTS

Examiner Initials	Document No	Publication Date	Name of Patentee or Applicant of Cited Document	Class	Subclass	Filing Date
AG	US-4,892,753 4,892,753	01-09-1990	WANG ET AL.	427	38	10-25-1988
	US-5,040,046	08-13-1991	CHHABRA ET AL.	357	54	10-09-1990
	US-5,643,838	07-01-1997	DEAN ET AL.	437	238	09-03-1993
	US-5,660,895	08-26-1997	LEE ET AL.	427	579	04-24-1996
	US-5,888,413	03-30-1999	OKUMURA ET AL.	216	68	05-30-1996
	US-6,096,661	08-01-2000	NGO ET AL.	438	788	12-15-1998
	US-6,174,450 B1	01-16-2001	PATRICK ET AL.	216	61	04-16-1997
	US-6,174,743 B1	01-16-2001	PANGRL ET AL.	438	14	12-08-1998
	US-6,303,519 B1	10-16-2001	HSIAO	438	758	07-20-2000
AG	US-6,426,015 B1	07-30-2002	XIA ET AL.	216	62	12-14-1999

8/27/03

FOREIGN PATENT DOCUMENTS

Examiner Initials	Foreign Patent Document	Publication Date	Country	Name of Patentee or Applicant of Cited Document	Translation? (Yes/No/n/a)

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	
AG	Van de Ven, Evert P., Connick, I-Wen, and Harrus, Alain S., "ADVANTAGES OF DUAL FREQUENCY PECVD FOR DEPOSITION OF ILD AND PASSIVATION FILMS," IEEE, Proceedings of VMIC Conference, June 12-13, 1990, pp. 194-201.

Examiner's Signature:

AG

Date Considered:

7/7/07

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.